



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 1, 2026

IGI Report Number

LG788612306

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

OVAL BRILLIANT

Measurements

9.42 X 6.56 X 4.11 MM

GRADING RESULTS

Carat Weight

1.57 CARAT

Color Grade

D

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

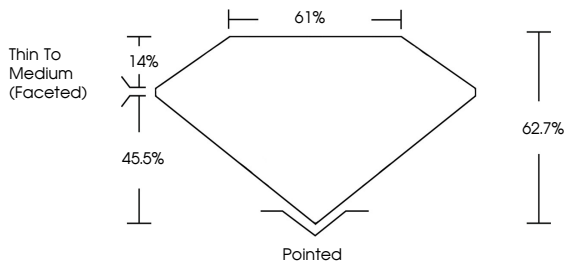
Inscription(s)

 LG788612306

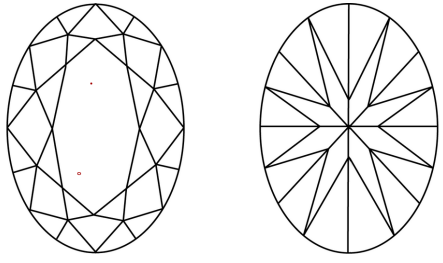
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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D

Color Grade

D

VS 1

Clarity Grade

VS 1

62.7%

Depth

62.7%

61%

Table

61%

Thin To Medium (Faceted)

Girdle

Thin To Medium (Faceted)

Pointed

Culet

Pointed

EXCELLENT

Polish

EXCELLENT

EXCELLENT

Symmetry

EXCELLENT

NONE

Fluorescence

NONE

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